



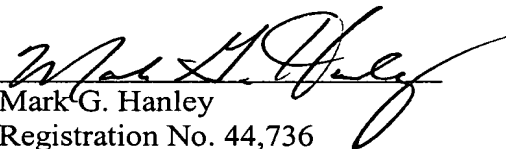
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Geon-Ook Park
U.S. Serial No. : 10/817,096
Filed : April 2, 2004
Title : "Semiconductor Device
and Fabrication Method
Thereof"

Art Unit : 2811
Examiner : Long Pham

) I hereby certify that this paper (and/or
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)

Dated: July 6, 2005


Mark G. Hanley
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Attorney for Applicant

RESPONSE TO THE OFFICE ACTION DATED JUNE 7, 2005

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

In response to the Office action dated July 6, 2005, please enter the following
amendments and consider the following remarks:

Amendments to the claims begin on page 2 of this paper.

Remarks begin on page 10 of this paper.

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